



IPW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Jun HATAKEYAMA et al.

Group Art Unit: 1752

Application No.: 10/797,201

Filed: March 11, 2004

Docket No.: 118988

For: AN ANTI-REFLECTION FILM MATERIAL AND A SUBSTRATE HAVING AN  
ANTI-REFLECTION FILM AND A METHOD FOR FORMING A PATTERN

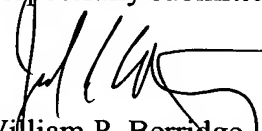
**STATUS INQUIRY LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the next communication can be expected.

Respectfully submitted,

  
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